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April 26, 2005

VIA FACSIMILE
EXPEDITED PROCEDURE

To: Examiner Julio Maldonado Facsimile No. 703-872-9306
 Group Art Unit No. 2823
 U. S. P. T. O.

From: Phillip E. Miller Facsimile No. 703-761-2375

Re: Filing of Amendment
 U. S. Patent Application Serial No. 09/851,313
 Our Ref: WAK.084

Dear Examiner:

Enclosed please find an Amendment which is filed in response to the non-final Office Action dated January 26, 2005, and which should place this Application in condition for allowance.

Thank you in advance for your kind consideration of this case.

Very truly yours,

 Phillip E. Miller

PEM/lnb
 Enclosure

APR 26 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Tatsuya Usami

Serial No.: 09/851,313

Group Art Unit: 2823

Filed: May 9, 2001

Examiner: Maldonado, Julio J.

For SEMICONDUCTOR DEVICE AND SEMICONDUCTOR WAFER HAVING A
MULTI-LAYERED INSULATION FILMHonorable Commissioner of Patents
Alexandria, Virginia 22313-1450AMENDMENT UNDER 37 C.F.R. §1.111

Sir:

In response to the Final Office Action dated January 26, 2005, please amend the
above-identified application as follows: